



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

Inventors : Alexander Leybovich
Serial No. : 10/624,384
Filed : July 22, 2003
Title : Method and Apparatus for Deposition
Of Low-K Dielectric Materials
Examiner : Steven H. VerSteeg
Art Unit : 1753
Docket No. : 020324 227P2
Customer No.: 33,805

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

AMENDMENT UNDER 37 C.F.R. 1.111

In response to the Office Action mailed March 22, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

DEPOSIT ACCOUNT USE AUTHORIZATION

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